

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application No. : U.S. National Stage of PCT/JP2004/012470
Applicant : N. Saeki
Filed : Mar. 20, 2006
Title : Plasma Processing Method and Apparatus thereof
Docket No. : SAEK3001/FJD
Customer No. : 23364

INFORMATION DISCLOSURE STATEMENT

COMMISSIONER FOR PATENTS
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:


Pursuant to 37 C.F.R. §1.51(b), §1.56, §1.97, and §1.98, this Information Disclosure Statement is submitted in the above-identified patent application. A listing of documents to be published on the face of any patent granted from this application is submitted herewith on Form PTO-1449. A copy of each document listed on form PTO-1449 is submitted herewith (with the exception of the U.S. references).

This Information Disclosure Statement is submitted within three months of the filing date of the above-identified U.S. Patent application.

The Examiner is requested to acknowledge consideration of the information provided in this paper in accordance with prescribed procedures.

Respectfully submitted,

Date: March 20, 2006


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B/O Form PTO-1449 U.S. Department of Commerce Patent and Trademark Office Information Disclosure Statement by Applicant	Atty. Docket Number	Serial Number
	SAEK3001/FJD	10/572648
	Applicant	
	Noboru Saeki	
	Filing Date	Group
	March 20, 20026	Unassigned

U.S. Patent Documents

Examiner Initial	Document Number	Date	Patentee/Applicant	Class	Subclass	Filing Date if Appropriate

Foreign Patent Documents

Examiner Initial	Document Number	Publication Date	Country/Agency	Class	Subclass	Translation	
						Yes	No
	JP 2002-158219 A	31/May/02	Japan				
	JP 7226395	22/Aug/95	Japan				
	JP 5059198	09/Mar/93	Japan				
	JP 2002 332572	22/Nov/02	Japan				
	JP 11512651T	02/Nov/99	Japan				
	JP 2002 305070	18/Oct/02	Japan				
	JP 2003 086393	20/Mar/03	Japan				
	JP 11060759	05/Mar/99	Japan				

Other Documents (Including Author, Title, Date, Pertinent Pages, Place of Publication, Etc.)

Examiner	Date Considered
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EXAMINER: Initial if citation is considered, whether or not citation is in conformance with MPEP 609; Draw a line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.